	Application No.	Applicant(s)
Notice of Allowability	09/724,403	MAEKAWA, SHINJI
	Examiner	Art Unit
	Stephen W. Smoot	2813
The MAILING DATE of this communication apply All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313  1.  This communication is responsive to applicant's amendment	ears on the cover sheet with the (OR REMAINS) CLOSED in this ) or other appropriate communicat IGHTS. This application is subject and MPEP 1308.	application. If not included tion will be mailed in due course. THIS
2. X The allowed claim(s) is/are 1-6,20-30,44,50,52,58,61-67 a	and 71.	
3. ☑ Acknowledgment is made of a claim for foreign priority unally a) ☑ All b) ☐ Some* c) ☐ None of the:  1. ☑ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have	e been received. e been received in Application No	·
International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  4.  A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv	MENT of this application.  nitted. Note the attached EXAMIN	ER'S AMENDMENT or NOTICE OF
5. CORRECTED DRAWINGS ( as "replacement sheets") mu	st be submitted.	
(a) ☐ including changes required by the Notice of Draftsper		rO-948) attached
1)  hereto or 2) to Paper No./Mail Date		,
(b) including changes required by the attached Examiner Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the same page 1.	1.84(c)) should be written on the dra	awings in the front (not the back) of
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT		
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informa 6. ☐ Interview Summ Paper No./Mail 7. ☒ Examiner's Ame 8. ☒ Examiner's State 9. ☐ Other	ary (PTO-413), Date
Storage W/ Sm	ent	Stephen W. Smoot Patent Examiner Art Unit 2813

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**EXAMINER'S AMENDMENT** 

This Office action is in response to applicant's amendment filed on 08 August

2006.

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes

and/or additions be unacceptable to applicant, an amendment may be filed as provided

by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be

submitted no later than the payment of the issue fee.

2. The application has been amended as follows:

In the Specification:

Change the Title of the Invention to --Method of Manufacturing a Semiconductor

Device that Includes Forming a Material with a High Tensile Stress in Contact

with a Semiconductor Film to Getter Impurities from the Semiconductor Film--.

In the Claims:

Cancel claims 7-19, 31-43, 45-49, 51, 53-57, 59-60, 68-70.

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## Response to Arguments

3. Applicant's argument, see pages 1-2, filed on 08 August 2006, with respect to the tensile stress limitation has been fully considered and is persuasive. Specifically, the applicant's originally filed specification at page 34, lines 6-16 shows that the tensile stress of the material depends on other factors (e.g. gettering temperature and gettering time) besides just the type of material used. Accordingly, the presumption of inherency cannot be maintained and the rejection of claims 61, 65-66, 71 under 35 USC 103(a) has been withdrawn.

## Election/Restrictions

4. Claims 61, 65-66, 71 are allowable. The restriction requirement among species, as set forth in the Office action mailed on 30 November 2005, has been reconsidered in view of the allowability of claims to the elected invention pursuant to MPEP § 821.04(a). The restriction requirement is hereby withdrawn as to any claim that requires all the limitations of an allowable claim. Claims 1-6, 20-30, 44, 50, 52, 58, 62-64, 67, directed to species that include the limitation "forming a material having a tensile stress of 8 x 10<sup>9</sup> dynes/cm<sup>2</sup> or more in contact with the semiconductor film" are no longer withdrawn from consideration because this claim limitation distinguishes claims 1-6, 20-30, 44, 50, 52, 58, 62-64, 67 from the prior art made of record. However, claims 7-19,

31-43, 45-49, 51, 53-57, 59-60, 68-70, remain withdrawn from consideration because they are directed to species that do not include this claim limitation.

In view of the above noted withdrawal of the restriction requirement, applicant is advised that if any claim presented in a continuation or divisional application is anticipated by, or includes all the limitations of, a claim that is allowable in the present application, such claim may be subject to provisional statutory and/or nonstatutory double patenting rejections over the claims of the instant application.

Once a restriction requirement is withdrawn, the provisions of 35 U.S.C. 121 are no longer applicable. See *In re Ziegler*, 443 F.2d 1211, 1215, 170 USPQ 129, 131-32 (CCPA 1971). See also MPEP § 804.01.

5. This application is in condition for allowance except for the presence of claims 7-19, 31-43, 45-49, 51, 53-57, 59-60, 68-70 directed to species non-elected without traverse. Accordingly, claims 7-19, 31-43, 45-49, 51, 53-57, 59-60, 68-70 have been cancelled.

## Allowable Subject Matter

- 6. Claims 1-6, 20-30, 44, 50, 52, 58, 61-67, 71 are allowed.
- 7. The following is an examiner's statement of reasons for allowance: Claims 1-6, 20-30, 44, 50, 52, 58, 61-67, 71 are allowed because the prior art of record does not

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teach or suggest, in combination with the other claim limitations, a method of manufacturing a semiconductor device that includes forming a material having a tensile stress of 8 x 10<sup>9</sup> dynes/cm<sup>2</sup> or more in contact with a semiconductor film, whereby an impurity element is gettered into the material.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stephen W. Smoot whose telephone number is 571-272-1698. The examiner can normally be reached on M-F (8:00 am to 4:30 pm).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

**SWS**